



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ammar Derraa

Serial No.: 10/654,226

Filed: September 2, 2003

For: METHOD OF FABRICATING FIELD
EMISSION ARRAYS EMPLOYING A
HARD MASK TO DEFINE COLUMN
LINES AND ANOTHER MASK TO
DEFINE EMITTER TIPS AND RESISTORS

Confirmation No.: 4741

Examiner: Unknown

Group Art Unit: 2879

Attorney Docket No.: 2269-3882.8US

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 1, 2004
Date

Signature

Deidra J. Pfeil
Name (Type/Print)

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

Please revise the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.